

Sensors and Materials

Special Issue on Nanostructure and Its Application in Sensors

Call for Papers

Nanostructures are becoming more and more popular in high-performance sensors, not only because of the availability of materials but also the highly efficient transition of energy at nanoscale. With the help of nanostructures, high sensitivity, high selectivity, as well as high stability may be achieved partly or completely in sensors. This special issue will focus on state-of-the-art nanostructure and its applications in sensors, and it will discuss materials, fabrication methods, and high-performance sensors.

Scope:

- High-sensitivity nano materials
- Batch fabrication method for nano sensors
- High-efficiency nano transducers
- Micro and nano fused sensors
- Other related areas

Submission due date: ~~April 30, 2018~~ extended to May 31, 2018

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Journal website: <http://myukk.org>

Guest Editor: Tie Li (Shanghai Institute of Microsystem and Information Technology)

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(Attention)

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If you have any questions, please feel free to contact the editorial staff at the address below.

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